

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Shin-itsu TAKEHASHI et al.

Prior Group

Art Unit: 2815

Serial No.: Rule 1.53(b) Divisional
of SN 09/700,132
filed November 9, 2000

Prior Examiner:

George C. Eckert II

Filed: June 30, 2003

For: THIN-FILM TRANSISTOR, PANEL,
AND METHODS FOR PRODUCING THEM

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1405
Alexandria, Virginia 22313-1450

Sir:

Pursuant to 37 C.F.R. §1.56, the attention of the U.S. Patent and Trademark Office is hereby directed to the references listed on the attached Form PTO-1449.

The listed references were cited during prosecution of patent application Serial No. 09/700,132 filed November 9, 2000, and copies of each reference may be found in the USPTO file for the parent application.

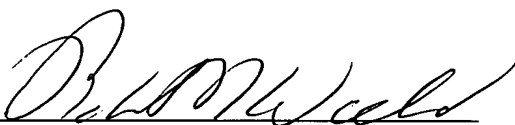
The above information is presented so that the U.S. Patent and Trademark Office may, in the first instance, determine any materiality thereof to the claimed invention. See 37 C.F.R. §1.104(a) and §1.106(b) concerning the USPTO duty to consider and

use any such information. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that these references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

Respectfully submitted,

PARKHURST & WENDEL, L.L.P.

June 30, 2003
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RWP:RNW/mhs

Attorney Docket No.: OGOH:053A

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FORM PTO 1449 (modified)

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICELIST OF REFERENCES CITED BY APPLICANT(S)
(Use several sheets if necessary)ATTY DOCKET NO.
OGO:053ASERIAL NO.
Rule 1.53(b) Div of SN 09/700,132 filed November 9.APPLICANT
Shin-itsu TAKEHASHI et al.FILING DATE
June 30, 2003GROUP
2815

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	5,089,863	02/1992	Satoh et al.	257	388	
	5,471,080	11/1995	Satoh et al.	257	344	
	5,880,015	03/1999	Hata	438	585	
	5,977,586	11/1999	Crisenza et al.	257	326	
	5,989,967	11/1999	Gardner et al.	438	305	
	5,981,383	11/1999	Lur et al.	438	655	
	6,069,387	05/2000	Gardner	257	344	
	6,284,613	09/2001	Subrahmanyam et al.	438	307	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION NO YES	
	3-61-36975	02/1986	Japan	257	344		
	3-63-9154	01/1998	Japan	438	158		
	4-2-226727	09/1990	Japan	438	305		
	4-5-21454	01/1993	Japan	H01L	21/336		
	4-5-243261	09/1993	Japan	257	408		
	4-6-260645	09/1994	Japan	H01L	29/784		
	3-60-127761	07/1985	Japan	H01L	29/78		

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

"Spacer Formation on Electrodes with Non-Vertical Sidewalls," IBM Technical Disclosure Bulletin, Nov. 1, 1984, Vol. 27, No. 6,
TDB-ACC-No. NN84113464, pp 3464-66.

EXAMINER:

DATE CONSIDERED:

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.